UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/537,109	11/23/2005	Terrance L Winnington	66515-0001	1276
	7590 07/18/200 MAN & GRAUER PL	EXAMINER		
39533 WOODWARD AVENUE			BHAT, NINA NMN	
	SUITE 140 BLOOMFIELD HILLS, MI 48304-0610		ART UNIT	PAPER NUMBER
			1797	
			MAIL DATE	DELIVERY MODE
			07/18/2008	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)			
	10/537,109	WINNINGTON ET AL.			
Office Action Summary	Examiner	Art Unit			
	N. Bhat	1797			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim vill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).			
Status					
1) Responsive to communication(s) filed on <u>6-02-</u>	action is non-final. nce except for formal matters, pro				
Disposition of Claims					
4) Claim(s) 1-16 is/are pending in the application. 4a) Of the above claim(s) 4,5,10,11 and 16 is/a 5) Claim(s) is/are allowed. 6) Claim(s) 1-3,6-9 and 12-15 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/or Application Papers 9) The specification is objected to by the Examine	re withdrawn from consideration. r election requirement.				
10) ☐ The drawing(s) filed on <u>02 June 2005</u> is/are: a) ☐ accepted or b) ☐ objected to by the Examiner. Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.					
Priority under 35 U.S.C. § 119					
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 					
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 6-2-2005.	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:	nte			

Application/Control Number: 10/537,109 Page 2

Art Unit: 1797

DETAILED ACTION

1. The disclosure is objected to because of the following informalities: Applicant is required to include the heading "Brief Description of the Drawings" as well as a brief description of each of the drawings filed with the application. Appropriate correction is required.

- 2. Claims 4-5, 10-11 and 16 are objected to under 37 CFR 1.75(c) as being in improper form because a multiple dependent claim can not depend from a multiple dependent claim. See MPEP § 608.01(n). Accordingly, the claims 4-5, 10-11 and 16 will not been further treated on the merits.
- 3. Claims 1-5 are rejected under 35 U.S.C. 112, second paragraph, as being incomplete for omitting essential structural cooperative relationships of elements, such omission amounting to a gap between the necessary structural connections. See MPEP § 2172.01. The omitted structural cooperative relationships are: providing the reactor housing, the location of the supporting elements within the reactor housing, the location and of the rotating element within the reactor, the inlets and outlets for introducing fluid streams into the reactor. In claim 2, it is not clear what is meant by "means for controlling the residence time" the means should be recognizable. In claim 3, applicant recites that the means for controlling the residence time are perforations or edge features, where are these features located; there is no construction and arrangement of these means within the reactor and cooperating with the parts within the reactor. In claim 5, the term planes with respect to the apparatus generally mean to the artisan the orientation of elements, it is not clear what applicant means by planes in the form of cones, truncated cones, separates or coherent packings.
- 4. Claims 6-16 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention. Claims 6 should be drafted as an independent claim and should not depend from

Application/Control Number: 10/537,109 Page 3

Art Unit: 1797

the apparatus. The process does not further limit the apparatus. The process claims lack clarity in this form. Claim 6 should be drafted as an independent claim, claming the method of using the apparatus and should include the features of the apparatus within the body of the claim. Independent claims 11 and 12 lack clarity mostly because the apparatus as claimed is not clear as it is unclear what are the features of the thin-film reactor? It is not clear how the process takes place using the reactor as claimed. Suitable explanation and correction is required. Applicant is invited to speak with the Examiner in order to ensure the 112, second paragraph and objections are addressed and if any further assistance is required in order to expedite prosecution if so desired.

- 5. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:
 - (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 6. Claims 1-3, 6-9 and 12-15 are rejected under 35 U.S.C. 102(b) as being anticipated by Ramshaw et al., US Patent 6,972,113.

Ramshaw teaches a spininng disc reactor which icnldues a plurality of rotatable discs having a surface on which reactant (15) is supplied by way of a feed (4). The disc is rotated at a high speed and the reactant spills over the surface to form a thin film. The surface (5) is enhanced by using means surface such as a metal mesh which increases the residence time of the reactant (15) on the surface (5) and helps in mixing.[Note the abstract] Ramshaw et al. teach that the feed means may be provided at any suitable potion with respect to the rotating surface which allows feed of the reactant. The feed means can be axially aligned with the rotating surface for axial feed. Alternatively the feed means can be positioned such that the feed is paced from the axis of the rotating surface, this arrangement can lead to more turbulence and

Application/Control Number: 10/537,109

Page 4

Art Unit: 1797

enhanced mixing. Reactant flow from the feed out and subsequently spread out of the trough onto the rotating surface by centrifugal force.[Note Column 5, lines 6-21] Ramshaw et al. teach that there may be provided two generally planar support elements mounted coaxially and generally parallel to each other on an axis of rotation. The facing surfaces of the support elements may be provided with at least one generally circular wall defined about the axis of rotation. And a plurality of concentric walls being divergent with respect to the axis of rotation of the respective support element as shown in Figure 17. The apparatus as described by Ramshaw et al. specifically teaches an centrifugal reactor which residence time control and process of using the apparatus wherein the supporting elements are rotated which provide an enhanced gravitational filed, wherein one or more reactants can be introduced on the surface for effecting chemical reactions employing thin film technology that can be used in a spinning cone reactor. Ramshaw et al. teach that the apparatus includes notches and other edge features and perforations in an inclined support plane carrying liquid in an enhanced gravitational field. The process of using the Ramshaw et al. renders applicant's process unpatentable and the apparatus as claimed by Ramshaw et al. is fully capable of performing the steps of reacting two chemical reactants on a apparatus for chemical process comp rosining a axis about which a plurality of supporting laments are rotated to provide an enhanced gravitational field; each support elements are inclined to the axis wherein an a flowable and reactive component can pass from one support element in a controlled way. The flows of the feed materials or reactant although not specified in terms of the Reynolds number, the flows provided on the spinning disc reactor is inherently capable of providing flows having Reynolds numbers within the range as claimed by applicant and applicant's apparatus and process are fully anticipated by Ramshaw et al.

Application/Control Number: 10/537,109 Page 5

Art Unit: 1797

7. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Ramshaw et al."063' teach a rotating surface of revolution reactor with shearing

mechanisms. Vander May et al. teach a thin film rotating reactor. Hull teaches a method of

operating surface reactors.

8. Any inquiry concerning this communication or earlier communications from the examiner

should be directed to N. Bhat whose telephone number is 571-272-1397. The examiner can

normally be reached on Monday-Friday, 9:30AM-6:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Glenn Caldarola can be reached on 571-272-1444. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have guestions on access to the Private

PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you

would like assistance from a USPTO Customer Service Representative or access to the

automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/N. Bhat/

Primary Examiner, Art Unit 1797